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PTO/SB/08A (08-00)

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<b>Substitute for form 1449A/PTO</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	09/884,205
				Filing Date	June 19, 2001
				First Named Inventor	Matthew D. Ellis
				Group Art Unit	Not Yet Assigned 1763
				Examiner Name	Not Yet Assigned Olsen
Sheet	1	of	2	Attorney Docket Number	DO-050767/P006US/10006222

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
And	A	09/569,328		Ellis et al.		
	B	09/569,329		Parker et al.		
	C	09/569,330		Merkle et al.		
	D	09/570,170		Ellis et al.		
	E	09/616,500		Ellis et al.		
	F	09/643,011		Ellis et al.		
	G	4,740,410		Muller et al.	04-26-1988	
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	I	5,660,580		Keller	08-26-1997	
	J	3,439,416		Yando	04-22-1969	
	K	5,806,152		Saitou	09-15-1998	
And	L	5,818,748		Bertin	10-06-1998	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>3</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				

Examiner Signature	<i>Alta Olsen</i>	Date Considered	11-1-2005
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Sheet	2	of	2	Attorney Docket Number	DO-050767/P006US/10006222

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS				
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>	
MEU	M	Thermal Microactuators for Surface Micromachining Processes, Proceedings of the SPIE, V 2642, p. 10-21, 1995.		
	N	A New Pick Up & Release Method By Heating For Micromanipulation, by Fumihito Arai and Toshio Fukuda, January 1997		
	O	Advanced Parts Orientation System Has Wide Application, by H. Hitakawa, August 1988		
	P	Design, Fabrication, and Characterization of Single Crystal Silicon Latching Snap Fasteners for Micro Assembly, by Rama Prasad et al., Nov. 1995		
	Q	Fluidic Self-Assembly of Microstructures and its Application to the Integration of GaAs on Si, by Hsi-Jen J. Yeh and John S. Smith, January 1994		
	R	Hexsil Tweezers for Teleoperated Microassembly, by C. G. Keller and R. T. Howe, January 1997		
	S	Microassembly Technologies for MEMS, by Michael B. Cohn et al		
	T	Microfabricated High Aspect Ratio Silicon Flexures, by Chris Keller, 1998		
	U	Self-Assembling Electrical Networks: An Application of Micromachining Technology, by Michael B. Cohn et al., May 1991		
	V	Surface-Micromachined Components for Articulated Microrobots, by Richard Yeh, et al., March 1996		
MEU	W	Survey of Sticking Effects for Micro Parts Handling, by Ronald S. Fearing, April 1995		

Examiner Signature	<i>Alta Ober</i>	Date Considered	11-1-2005
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